	Application No.	Applicant(s)
Notice of Allowability	10/773,799 Examiner	FUMITAKE et al. Art Unit
	Lee, Calvin	2818
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap or other appropriate communication GHTS. This application is subject to	plication. If not included not will be mailed in due course. THIS
1. \boxtimes This communication is responsive to <u>Amendment dated Ju</u>	ne 6, 2005	
2. The allowed claim(s) is/are <u>1-19</u> .		
3. \boxtimes The drawings filed on <u>06 February 2004</u> are accepted by the	ne Examiner.	
 4. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application No	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submit	ENT of this application.	
INFORMAL PATENT APPLICATION (PTO-152) which give		
6. X CORRECTED DRAWINGS (as "replacement sheets") mus		
(a) ☐ including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO-	-948) attached
 1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☒ including changes required by the attached Examiner's Paper No./Mail Date here to 	s Amendment / Comment or in the C	Office action of
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the		
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I		
Attachment(s)		·
1. Notice of References Cited (PTO-892)		Patent Application (PTO-152)
2. Motice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary Paper No./Mail Dat	te
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date		
4. Examiner's Comment Regarding Requirement for Deposit	_/ _	ent of Reasons for Allowance
of Biological Material	9. Other	
David Nelms		
Supervisory Patent Examiner Technology Center 2800		
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FUMITAKE et al.

OFFICE ACTION

Allowable Subject Matter

Claims 1-19 are allowed. Following is a statement reason for claims' allowance:

The closest prior art, US 6,242,332 to *Cho et al*, does not disclose, *inter alia*, a second etching process to remove a portion of a conformal dielectric layer on a bit line region, a portion of the conformal dielectric layer on the capacitor contact region while using other portions of the conformal dielectric layer and each of the caps as a mask to prevent the first gate structure and the

second gate structure to be exposed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid delays, should preferably accompany the issue fee. Such submissions

should be clearly labeled "Comments on Statement of Reasons for Allowance.

Contact Information

Any inquiry concerning this communication from the Examiner should be directed to *Calvin Lee* at (571) 272-1896 on Mondays thru Thursdays 6:30-4:30PM. If attempts to reach the examiner by telephone are unsuccessful, Art Unit 2818's Supervisory Patent Examiner *David Nelms* can be reached at (571) 272-1787. The fax phone number for the organization (where this application is

assigned to) is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system at http://pair-direct.uspto.gov. Should you have questions on access to the PAIR system, contact the Electronic Business Center at (866) 217-9197.

David Nams
Supervisory Patent Examiner
Technology Control 2800

Date: June 14, 2005 Technology Centar 2800